

IN THE SPECIFICATION

Please enter the following amendment to the Specification:

Please amend paragraph 0038 to read as follows:

**[0038]** The second image sensor ~~436~~236 may be configured or made of materials to detect different wavelengths than the first image sensor ~~430~~230. For example, the first image sensor ~~430~~230 may have detector materials to detect light in the near infrared (NIR) or medium-wave infrared (MWIR) ranges while the second image sensor ~~436~~236 may be made from detector material(s) sensitive to visible light. For example, in certain embodiments, the second image sensor ~~436~~236 may have peak detectivity near 700 nm. Semiconductor detector materials for the first and second image sensors ~~430, 436~~230, 236 may be selected based on bandgap energies and corresponding detection capabilities.